



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
SHIN KITAMURA ET AL.	:	Examiner: NYA
Application No.: 09/940,643	:)	Group Art Unit: 2879
Filed: August 29, 2001	;	
For: ELECTRON-EMITTING DEVICE, ELECTRON SOURCE, IMAGE- FORMING APPARATUS, AND METHOD FOR PRODUCING ELECTRON-EMITTING DEVICE AND ELECTRON-EMITTING APPARATUS	;	June 11, 2003

INFORMATION DISCLOSURE STATEMENT

Sir:

Mail Stop DD

P.O. Box 1450

Commissioner for Patents

Alexandria, VA 22313-1450

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

A Chinese Office Action (copy enclosed with English translation thereof) has issued in a foreign counterpart application citing CN 1181607A and WO 99/58748A1 as

references. A copy of CN 1181607A could not be obtained. However, EP 0 836 217 A1 has been identified as an English equivalent of the CN 1181607A reference (See attached Document Bibliography and Abstract for EP0836217). The Chinese Office Action issued not more than three months prior to the filing of this Information Disclosure Statement.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered. No fee is believed required in connection with this Information Disclosure Statement.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 477

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801

FORM PTO 1449 (modified)		ATTY DOCKET NO. APPLICATION NO. 03500.015729			09/940,643				
L F	J.S. DEPARTMENT OF COMMER PATENT AND TRADEMARK OFFI	PEVCIN	APPLICANT						
LIST O	F REFERENCES CITED BY APPLICATION OF REFERENCES CITED BY APPLICATION OF REFERENCES APPLICATION O	CANT(S)	M SHIN KITAMUKA ETAL.						
l \\			FILING DATE August 29, 2001		GROUP	GROUP 2879			
U.S. PATENT DOCUMENTS									
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE			
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		- 10 0							
FOREIGN PATENT DOCUMENTS									
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT			
	0 836 217 A1	4/1998	EPO	H01J	29/94				
•	99/58748	11/1999	wo	D01F	9/127				
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	ОТІ	HER DOCUMENT(S)	(Including Author, Title, Date, Pertinen	t Pages, Etc.)					
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EXAMINER DATE CONSIDERED									

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.